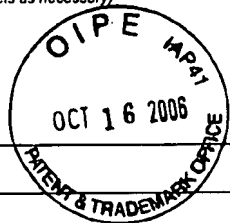


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	Application Number	09/382,929
	Filing Date	August 25, 1999
	First Named Inventor	Farrar, Paul
	Group Art Unit	2822
	Examiner Name	Graybill, David
Sheet 1 of 3	Attorney Docket No: 303.603US1	



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Substitute for form 1449A/PTO <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(Use as many sheets as necessary)</i>	<table border="1" style="width: 100%; border-collapse: collapse;"> <tr> <td colspan="2" style="padding: 2px;"><i>Complete if Known</i></td> </tr> <tr> <td style="width: 40%; padding: 2px;"><b>Application Number</b></td> <td style="padding: 2px;">09/382,929</td> </tr> <tr> <td style="padding: 2px;"><b>Filing Date</b></td> <td style="padding: 2px;">August 25, 1999</td> </tr> <tr> <td style="padding: 2px;"><b>First Named Inventor</b></td> <td style="padding: 2px;">Farrar, Paul</td> </tr> <tr> <td style="padding: 2px;"><b>Group Art Unit</b></td> <td style="padding: 2px;">2822</td> </tr> <tr> <td style="padding: 2px;"><b>Examiner Name</b></td> <td style="padding: 2px;">Graybill, David</td> </tr> </table>	<i>Complete if Known</i>		<b>Application Number</b>	09/382,929	<b>Filing Date</b>	August 25, 1999	<b>First Named Inventor</b>	Farrar, Paul	<b>Group Art Unit</b>	2822	<b>Examiner Name</b>	Graybill, David
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